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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8243  
Takeshi IWAI et al. : Docket No. 2001-1761A  
Serial No. 09/993,627 : Group Art Unit 1752  
Filed November 27, 2001 : Examiner John S.Y. Chu

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POSITIVE-WORKING PHOTORESIST COMPOSITION

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RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
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ACCOUNT NO. 23-0975

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Sir:

This is in response to the Official Action dated March 27, 2003.